PATENT APPLICATION
Docket No. 8750-042
Client N . SPX200211-046US

Applicant:	**Dae-Woong Kang, Hong-Soo Kim, Jung-Dal Choi, Kyu-Charn Park, Seong-Soon Cho, Yong-Sik Yim and Sung-Nam Chang**		
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Serial No.	**10/758 802 ~~not yet assigned~~**	**Examiner:**	**not yet assigned**
For:	**METHODS OF FABRICATING A SEMICONDUCTOR DEVICE HAVING MULTI-GATE INSULATION LAYERS AND SEMICONDUCTOR DEVICES FABRICATED THEREBY**		

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam Init	Ref	Document Number	Issue Date	Name	Class	Sub Class
MCW	____	US 6,222,225 B1	4/24/2001	Nakamura, et al.		

Examiner: Matthew E. Warren

Date Considered: 3/13/05